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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Motoyuki Tsuihij et al.

Art Unit : 3723

Serial No. : 10/781,009

Examiner : Alvin J. Grant

Filed : February 18, 2004

Title : METHOD OF FABRICATING A SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 2, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

Oct. 4, 2004

Signature

Paula T. Romeo

PAULA T. ROMEO

Typed or Printed Name of Person Signing Certificate